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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/058,708	01/28/2002	Kay Hellig	1458.TT4978	7368
34456 7590 11/30/2005			EXAMINER	
TOLER & LARSON & ABEL L.L.P.			GUERRERO, MARIA F	
5000 PLAZA AUSTIN, TX	ON THE LAKE STE 265 78746		ART UNIT	PAPER NUMBER
,,,			2822	

DATE MAILED: 11/30/2005

Please find below and/or attached an Office communication concerning this application or proceeding.

		H.			
	Application No.	Applicant(s)			
	10/058,708	HELLIG ET AL.			
Office Action Summary	Examiner	Art Unit			
	Maria Guerrero	2822			
The MAILING DATE of this communication app Period for Reply	ears on the cover sheet with the	correspondence address			
A SHORTENED STATUTORY PERIOD FOR REPLY WHICHEVER IS LONGER, FROM THE MAILING DA  - Extensions of time may be available under the provisions of 37 CFR 1.13 after SIX (6) MONTHS from the mailing date of this communication.  - If NO period for reply is specified above, the maximum statutory period w  - Failure to reply within the set or extended period for reply will, by statute, Any reply received by the Office later than three months after the mailing earned patent term adjustment. See 37 CFR 1.704(b).	ATE OF THIS COMMUNICATION 36(a). In no event, however, may a reply be tinuity will apply and will expire SIX (6) MONTHS from cause the application to become ABANDONE	N. nely filed the mailing date of this communication. ED (35 U.S.C. § 133).			
Status					
1) Responsive to communication(s) filed on 08 No	ovember 2005				
· <u> </u>	action is non-final.				
3)☐ Since this application is in condition for allowar		osecution as to the merits is			
closed in accordance with the practice under E	·				
Disposition of Claims					
4) Claim(s) 1 and 18-33 is/are pending in the app	lication				
4a) Of the above claim(s) is/are withdrawn from consideration.					
5)⊠ Claim(s) <u>1,18 and 33</u> is/are allowed.					
6)⊠ Claim(s) <u>19-25 and 27-32</u> is/are rejected.					
7)⊠ Claim(s) <u>26</u> is/are objected to.					
8) Claim(s) are subject to restriction and/or	election requirement.				
Application Papers					
9) The specification is objected to by the Examine	r.				
10) The drawing(s) filed on is/are: a) accepted or b) objected to by the Examiner.					
Applicant may not request that any objection to the drawing(s) be held in abeyance. See 37 CFR 1.85(a).					
Replacement drawing sheet(s) including the correction is required if the drawing(s) is objected to. See 37 CFR 1.121(d).					
11) The oath or declaration is objected to by the Ex	aminer. Note the attached Office	Action or form PTO-152.			
Priority under 35 U.S.C. § 119					
12) Acknowledgment is made of a claim for foreign a) All b) Some * c) None of:  1. Certified copies of the priority documents		)-(d) or (f).			
<ul> <li>1. Certified copies of the priority documents have been received.</li> <li>2. Certified copies of the priority documents have been received in Application No</li> </ul>					
3. Copies of the certified copies of the prior	• •	<del></del>			
application from the International Bureau		ed in this National Stage			
* See the attached detailed Office action for a list of	* **	ed.			
	·				
Attachment(s)					
1) Notice of References Cited (PTO-892)	4) Interview Summary	(PTO-413)			
2) Notice of Draftsperson's Patent Drawing Review (PTO-948)	Paper No(s)/Mail Da				
3) Information Disclosure Statement(s) (PTO-1449 or PTO/SB/08) Paper No(s)/Mail Date	6) Other:	Patent Application (PTO-152)			

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## **DETAILED ACTION**

1. This Office Action is in response to the Amendment filed November 8, 2005. The finality of the Office Action mailed August 8, 2005 has been withdrawn.

## **Status of Claims**

2. Claims 2-17 are canceled. Claims 1 and 18-33 are pending.

# Claim Rejections - 35 USC § 102

The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

- (e) the invention was described in (1) an application for patent, published under section 122(b), by another filed in the United States before the invention by the applicant for patent or (2) a patent granted on an application for patent by another filed in the United States before the invention by the applicant for patent, except that an international application filed under the treaty defined in section 351(a) shall have the effects for purposes of this subsection of an application filed in the United States only if the international application designated the United States and was published under Article 21(2) of such treaty in the English language.
- 3. Claims 19-23, 25 and 32 are rejected under 35 U.S.C. 102(e) as being anticipated by Pradeep et al. (US 6,251,764).

Pradeep et al. shows forming a gate structure (88) on a substrate (80); forming a dielectric spacer layer (nitride layer) over the semiconductor substrate and etching the dielectric layer without the use of a sacrificial forming spacer, to form L-shaped spacers (100)(Fig. 8-9, col. 3, lines 30-65). Pradeep et al. discloses the L-shaped spacers including a first L-shaped spacer adjacent to a first sidewall of the gate structure and a second L-shaped spacer adjacent to a first sidewall of the gate structure (Fig. 9).

Pradeep et al. shows forming a liner oxide having a thickness between about 50 and

250 Angstroms over the gate structure (Fig. 8, col. 3, lines 20-32). Pradeep et al. teaches the dielectric spacer layer (nitride layer) thickness being from about 400 to about 1000 angstroms (col. 3, lines 30-50). Pradeep et al. shows anisotropically etching the dielectric spacer layer to form L-shaped spacers having vertical and horizontal portions varying in thickness (Fig. 8-9, col. 3, lines 30-55, col. 4, lines 15-25).

## Claim Rejections - 35 USC § 103

The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

(a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.

This application currently names joint inventors. In considering patentability of the claims under 35 U.S.C. 103(a), the examiner presumes that the subject matter of the various claims was commonly owned at the time any inventions covered therein were made absent any evidence to the contrary. Applicant is advised of the obligation under 37 CFR 1.56 to point out the inventor and invention dates of each claim that was not commonly owned at the time a later invention was made in order for the examiner to consider the applicability of 35 U.S.C. 103(c) and potential 35 U.S.C. 102(e), (f) or (g) prior art under 35 U.S.C. 103(a).

4. Claims 27-31 are rejected under 35 U.S.C. 103(a) as being unpatentable over Pradeep et al. (US 6,251,764) in view of Nishizawa (US 6,613,686).

Pradeep et al. does not specifically show etching the dielectric spacer layer with a chemistry combination of CH3F and O2 with an inert gas. However, Pradeep et al. teaches using CH3F, O2 and inert gas among others (col. 3, lines 40-65). In addition, Nishizawa discloses etching silicon nitride using a chemistry combination of CH3F and O2 with an inert gas (Fig. 2 and 4, column 6, line 30 to column 7, line 50). In regards to parameter ranges, these values would be optimized trough routine experimentation because there is not evidence of criticality. In re Aller, 220 F.2d 454, 456, 105 USPQ 233, 235 (CCPA 1955). In re Woodruff, 919 F.2d 1575, 16 USPQ2d 1934 (Fed. Cir. 1990). See MPEP § 716.02 - § 716.02(g).

Therefore, it would have been obvious to a person of ordinary skill in the art at the time of the invention to modify Pradeep et al. reference by etching the dielectric spacer layer using the etch chemistry combination of CH3F and O2 with an inert gas as taught by Nishizawa in order to obtain better etch selectivity.

5. Claim 24 is rejected under 35 U.S.C. 103(a) as being unpatentable over Pradeep et al. (US 6,251,764) in view of Verma (US 5,716,880).

Pradeep et al. does not specifically the dielectric spacer layer being silicon oxynitride. However, Verma discloses the spacers being made from a variety of materials including silicon oxide, silicon nitride and silicon oxynitride (col. 9, lines 35-65)

Therefore, it would have been obvious to a person of ordinary skill in the art at the time of the invention to modify Pradeep et al. reference by including the use of silicon oxynitride to form the dielectric spacer layer as taught by Verma because silicon nitride and silicon oxynitride are interchangeably used in semiconductor fabrication.

# Allowable Subject Matter

6. Claims 1, 18 and 33 are allowed.

Claim 26 is objected to as being dependent upon a rejected base claim, but would be allowable if rewritten in independent form including all of the limitations of the base claim and any intervening claims.

## Response to Arguments

7. Applicant's arguments with respect to claims 19-25 and 27-32 have been considered but are moot in view of the new ground(s) of rejection.

## Conclusion

8. Any inquiry concerning this communication or earlier communications from the examiner should be directed to Maria Guerrero whose telephone number is 571-272-1837.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Zandra Smith can be reached on 571-272-2429. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

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Business Center (EBC) at 866-217-9197 (toll-free).

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Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic

November 23, 2005

MARIA F. GUERRERO PRIMARY EXAMINER